



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q80781

Takeyoshi KANO, et al.

Appln. No.: 10/828,472

Group Art Unit: 1752

Confirmation No.: 5352

Examiner: Richard L. Schilling

Filed: April 21, 2004

For: PATTERN FORMING METHOD, IMAGE FORMING METHOD, FINE PARTICLE ADSORPTION PATTERN FORMING METHOD, CONDUCTIVE PATTERN FORMING METHOD, PATTERN FORMING MATERIAL AND PLANOGRAPHIC PRINTING PLATE

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 20, 2007, please amend the above-identified application as follows on the accompanying pages.

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